

**Notice of References Cited**

Application/Control No.

09/421,434

Applicant(s)/Patent Under

Reexamination

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Examiner

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Art Unit

3729

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**U.S. PATENT DOCUMENTS**

*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-3,610,969-	10-1971	Clawson et al	29	25.35
	B	US-4,099,407-	07-1978	Louit	73	1.82
	C	US-4,412,172-	10-1983	Vig	29	25.35
	D	US-5,004,985-	04-1991	Holroyd et al	324	727
	E	US-5,758,397-	06-1998	Inoi et al	29	25.35
	F	US-5,764,068-	06-1998	Katz et al	324	727
	G	US- -				
	H	US- -				
	I	US- -				
	J	US- -				
	K	US- -				
	L	US- -				
	M	US- -				

**FOREIGN PATENT DOCUMENTS**

*		Document Number	Date	Country	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY				
	N	JP-5-206539-	08-1993	Japan	Sasaki et al	29	25.35
	O	- -					
	P	- -					
	Q	- -					
	R	- -					
	S	- -					
	T	- -					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kawamura et al, Development of a High Voltage Sensor Using a Piezoelectric Transducer and a Strain Gage, Instrumentation and Measurement, IEEE Transactions, pages 564-568, Volume 37, Dec 1988.
	V	Brissaud, Characterization of Piezoceramics, Transactions on Ultrasonics, Ferroelectrics and Frequency Control, pages 603-617, Volume 38, Nov 1991.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.